

TSMC-00-166

May 13, 2003



To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

Subject:

Serial No. 09/679,514 10/06/00

Hung-Jen Hsu

"A METHOD TO IMPROVE PASSIVATION
OPENINGS BY REFLOW OF PHOTORESIST
TO ELIMINATE TAPE RESIDUE"

| Grp. Art Unit: 2823

B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated April 1, 2003,
please amend the above-identified application for patent as
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner for Patents
P.O. Box 1450, Alexandria, VA 22313-1450, on June 2,
2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature

Date 6/2/03

TECHNOLOGY CENTER 2800

JUN 10 2003

RECEIVED

#9/6
Amend
J. McAnally
6/11/03
7/15/03
V. Hsu

AK/2800